## Development of NbTiN-AI MKID camera for the Nobeyama 45-m telescope

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## Contents

- ✤ Scientific Motivation
- \* Microwave Kinetic Inductance Detector (MKID)
- \* MKID Camera for the Nobeyama 45-m telescope
- ★ Results of Lab Measurements
- ★ Future Development
- ★ Summary

# Survey of Distant Galaxies

#### ★ Distant Galaxy Survey

- distant galaxy is important source to understand the galaxy evolution
  - Optical : absorbed by dust
  - mm-wave to THz : dust emission
- multi-band observation
  - redshift can be determined from SED



#### ★ Star Formation History

- distant galaxy is obscured by dust
- wide-filed mm & submm continuum camera is important to survey galaxies



## Wide-Field Observations

#### $\star$ Multi-pixel camera for wide-field observations





ALMA : high-angular resolution interferometer

Fig. 4 A schematic illustration of the 10 m THz → follow-up observations of galaxies detected by the camera

telescope

- To observe a lot of distant galaxies,
  - camera development for wide-field observation
- good observation site for astronomical observations are important

# Camera Development

#### \* 100-GHz band Camera

- Camera will be installed on the Nobeyama 45m telescope
- Collaboration with National Astronomical Observatory of Japan
- free-free emission is dominant at the 100-GHz continuum
  - good tracer of the massive star forming region (HII region)

Observation Frequency	100-GHz band(90 – 110 GHz)
Field-of-view	$\sim$ 3 arcmin
Detector	Microwave Kinetic Inductance Detector
No. of pixels	109 pixels
Bath temperature	< 200 mK

#### \* THz band Camera (Future Plan)

- Our group is planning to construct the Ideg. FoV 10 m telescope at the Antarctica plateau.
- Target bands : 400 / 850 / 1300 GHz

MKID is one of the important technology for realizing wide-field camera



# Microwave Kinetic Inductance Detector (MKID)

### \* Operation Principle

- Superconducting resonators operated in the microwave range
- Incident photons break Cooper-pair
  - → Kinetic Inductance is changed
  - → Resonance frequency of MKID is also changed
- ex) AI MKID : > 85 GHz photons can be observed Gold : Superconductor(AI)

### \* Advantage of MKID

- High-detector yield is expected because the MKID fabrication process is relatively simple
- Intrinsic frequency multiplexing capability  $\rightarrow$  ~1000 pixels can be measured with one LNA







# Test Observations

Yates et al., 2011

#### \* <u>Commissioning in 2018 season</u>

- Optics, detector yield and stability satisfy a requirement
- Measured sensitivity was one order lower than the target sensitivity.



- \* Improvement of camera sensitivity
  - I. Low optical efficiency of MKID array
    - All AI MKID (gap E of AI : ~85 GHz)
      - Loss at GND & antenna ( = low efficiency)
    - NbTiN-AI MKID (gap E of NbTiN :  $\sim$  I.I THz)
      - NbTiN GND and Al signal line
  - 2. Surface reflection of Si lenses
    - high refractive index causes reflections of ~30% at lens surface





# Focal Plane Array

#### \*100-GHz band MKID Camera

- Double-slot antenna & Si lens array
- Glass beads AR coating

#### \*109 pixel NbTiN-Al MKID Array

- 200 nm NbTiN & 50 nm Al
- MKIDs are distributed over the entire
  3-inch Si wafer



#### < NbTiN-Al MKID >



#### fabricated by Y. Murayama

# Anti-Reflective Structures

#### \* <u>Subwavelength Structure (SWS)</u>

- Periodic structures in subwavelength scale
- · The structures act as antireflective (AR) layers
  - $\rightarrow$  ex) optimized for Si : n = 1.84



#### \* Fabrication Method

- Development of a dedicated three-axis dicing machine
  - (Oshima Prototype Engineering Co.)
  - $\rightarrow$ Lens surface can be machined
- Various (Rectangular and V-shape) types of dicing blades were used



## Lab Measurement

### \* Optical Measurement

- Detector Yield
- Frequency Response
- Beam Patterns
- \* <u>Camera Sensitivity</u>
  - Optical Efficiency
  - Noise Equivalent Power



Measured with Makoto Nagai (NAOJ), Yosuke Murayama (D3), Ryuji Suzuki, Ryotaro Hikawa, Rikako Suzuki (M2) and many collaborators

## Frequency Band Characteristic



## Beam Characteristic

#### \* Knife-Edge Measurement



#### Arnaud et al., 1971

- Scan thin blackbody (BB) source at a constant speed
  - 300 K and Li-N2 (77 K) BB sources were used to obtain the optical response
- Differential responses correspond to the beam shapes
  - Beam map (shape and position) can be obtained



• Beam waist size at the camera focal plane is almost the same as the simulation.

## Future Plan

# LeKID Array

#### \* Lumped Element Kinetic Inductance Detector (LeKID)

Collaboration with Université Grenoble Alpes



# Summary

### \* Scientific Motivation

- distant galaxy survey
  - wide-field survey is important to detect the unknown galaxies

### \* MKID Camera for the Nobeyama 45-m Telescope

- MKID is the superconducting resonator operated in the microwave range
- Camera development
  - 109 pixel array using lens-antenna coupled NbTiN-Al MKIDs
  - Results of beam pattern, yield and frequency response are as expected.
  - -This camera will be installed on the Nobeyama 45-m telescope in this Oct.
    - improvement of the multi-pixel readout system is needed

### ✤ Future Development

- Collaboration with Université Grenoble Alpes (LeKID development)
- $\sim$  20000 pixel camera is designed for the Antarctica 10 m telescope